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AUG 10 2005

PATENT APPLICATION  
Do. No. 4591-383  
Client No. IE10112-US-1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: You-Cheol SHIN, et al.

Serial No.: 10/777,233 Examiner: Brewster, William M.  
Filed: February 11, 2004 Group Art Unit: 2823  
For: SEMICONDUCTOR DEVICE AND METHOD OF  
MANUFACTURING THE SAME INCLUDING FORMING METAL  
SILICIDE GATE LINES AND SOURCE LINES (as amended)

Mail Stop Issue Fee  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT AFTER ALLOWANCE UNDER 37 CFR § 312

Responsive to the Notice of Allowance, dated May 11, 2005, please amend the application as follows.

OK to Enter

William M. Brewster

16 SEPS

Docket No. 4591-383  
Amendment After Allowance

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